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Attorney Docket No.: 4887P090

FEB 19 2002

IN RE: **APPARATUS AND METHOD FOR EXPOSING A SUBSTRATE TO PLASMA RADICALS**  
In Reply, Please Refer to the UNITED STATES PATENT AND TRADEMARK OFFICE

GUANGCAI XING, ET AL.

Application No.: 09/298,064

Filed: April 22, 1999

For: **APPARATUS AND METHOD FOR  
EXPOSING A SUBSTRATE TO  
PLASMA RADICALS**

Art Group: 1763

Examiner: Zervigon, R.

RECEIVED  
FEB 25 2002  
TC 1700

**PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. § 1.136(a), the Applicant for the above-identified application respectfully petitions the Commissioner for a one (1) month extension of time, extending the period for response to February 05, 2002, from the Notice of Appeal dated November 05, 2001. A check for \$110.00 (petition filing fee) and the RCE are attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal sheet is enclosed for deposit account charging purposes.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: January 31, 2002

*Raul D. Martinez*  
Raul D. Martinez, Reg. No. 46,904

12400 Wilshire Blvd., 7th Floor  
Los Angeles, California 90025  
Telephone: (310) 207-3800

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail with sufficient postage in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

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110.00 DP

January 31, 2002  
*Nadya Gordon*  
Nadya Gordon Date